

	Type	L #	Hits	Search Text	DBs	Time Stamp
1	BRS	L1	377584	interferometric or interferometer\$2 or interferenc\$4	USPAT; US-PGPU B; EPO; JPO; DERWENT ; IBM_TDB	2002/ 11/18 11:16
2	BRS	L2	86754	optical\$4 same (modulator\$2 or modulating or modulation or modulate\$2)	USPAT; US-PGPU B; EPO; JPO; DERWENT ; IBM_TDB	2002/ 11/18 11:17
3	BRS	L3	29866	holographic\$ or (photonic near4 crystal\$) or (dielectric\$ near4 mirror\$3) or (micro-lens\$2 or microlens\$2)	USPAT; US-PGPU B; EPO; JPO; DERWENT ; IBM_TDB	2002/ 11/18 11:23
4	BRS	L4	2780	1 and 2 and 3	USPAT; US-PGPU B; EPO; JPO; DERWENT ; IBM_TDB	2002/ 11/18 11:24
5	BRS	L6	13805	1 with (modulator or modulation or modulating or modulate\$2)	USPAT; US-PGPU B; EPO; JPO; DERWENT ; IBM_TDB	2002/ 11/18 11:26

	Type	L #	Hits	Search Text	DBs	Time Stamp
6	BRS	L7	1087	3 and 6	USPAT; US-PGPU B; EPO; JPO; DERWENT ; IBM_TDB	2002/ 11/18 11:26
7	BRS	L8	331	3 same 6	USPAT; US-PGPU B; EPO; JPO; DERWENT ; IBM_TDB	2002/ 11/18 11:26
8	BRS	L5	326	1 same 2 same 3	USPAT; US-PGPU B; EPO; JPO; DERWENT ; IBM_TDB	2002/ 11/18 11:28
9	BRS	L9	314	interferometric\$5 near3 modulator\$2	USPAT; US-PGPU B; EPO; JPO; DERWENT ; IBM_TDB	2002/ 11/18 11:28
10	BRS	L1 0	30	3 and 9	USPAT; US-PGPU B; EPO; JPO; DERWENT ; IBM_TDB	2002/ 11/18 11:28

	Type	Hits	Search Text	DBs	Time Stamp
1	BRS	377584	interferometric or interferometer\$2 or interferenc\$4	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 11:16
2	BRS	86754	optical\$4 same (modulator\$2 or modulating or modulation or modulate\$2)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 11:17
3	BRS	29866	holographic\$ or (photonic near4 crystal\$) or (dielectric\$ near4 mirror\$3) or (micro-lens\$2 or microlens\$2)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 11:23
4	BRS	2780	(interferometric or interferometer\$2 or interferenc\$4) and (optical\$4 same (modulator\$2 or modulating or modulation or modulate\$2)) and (holographic\$ or (photonic near4 crystal\$) or (dielectric\$ near4 mirror\$3) or (micro-lens\$2 or microlens\$2))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 11:24
5	BRS	13805	(interferometric or interferometer\$2 or interferenc\$4) with (modulator or modulation or modulating or modulate\$2)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 11:26

	Type	Hits	Search Text	DBs	Time Stamp
6	BRS	1087	(holographic\$ or (photonic near4 crystal\$) or (dielectric\$ near4 mirror\$3) or (micro-lens\$2 or microlens\$2)) and ((interferometric or interferometer\$2 or interferenc\$4) with (modulator or modulation or modulating or modulate\$2))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 11:26
7	BRS	331	(holographic\$ or (photonic near4 crystal\$) or (dielectric\$ near4 mirror\$3) or (micro-lens\$2 or microlens\$2)) same ((interferometric or interferometer\$2 or interferenc\$4) with (modulator or modulation or modulating or modulate\$2))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 11:26
8	BRS	326	(interferometric or interferometer\$2 or interferenc\$4) same (optical\$4 same (modulator\$2 or modulating or modulation or modulate\$2)) same (holographic\$ or (photonic near4 crystal\$) or (dielectric\$ near4 mirror\$3) or (micro-lens\$2 or microlens\$2))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 13:16
9	BRS	314	interferometric\$5 near3 modulator\$2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 13:16

	Type	Hits	Search Text	DBs	Time Stamp
10	BRS	30	(holographic\$ or (photonic near4 crystal\$) or (dielectric\$ near4 mirror\$3) or (micro-lens\$2 or microlens\$2)) and (interferometric\$5 near3 modulator\$2)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 11:28
11	BRS	314	interferometric\$5 near3 modulator\$2	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 13:33
12	BRS	3	((interferometric or interferometer\$2 or interferenc\$4) same (optical\$4 same (modulator\$2 or modulating or modulation or modulate\$2)) same (holographic\$ or (photonic near4 crystal\$) or (dielectric\$ near4 mirror\$3) or (micro-lens\$2 or microlens\$2))) and (interferometric\$5 near3 modulator\$2)	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 13:33
13	BRS	326	(interferometric or interferometer\$2 or interferenc\$4) same (optical\$4 same (modulator\$2 or modulating or modulation or modulate\$2)) same (holographic\$ or (photonic near4 crystal\$) or (dielectric\$ near4 mirror\$3) or (micro-lens\$2 or microlens\$2))	USPAT; US-PGPUB; EPO; JPO; DERWENT; IBM_TDB	2002/11/18 13:33

	Document ID	Source	Issue Date	Pages	Title	Current OR	Current XRef
1	JP 2000221871 A	<input checked="" type="checkbox"/> JPO	2000 0811	9	METHOD AND DEVICE FOR FORMATION OF HOLOGRAPHIC STEREOGRAM		
2	US 5039352 A	<input checked="" type="checkbox"/> US PAT	1991 0813	8	External wall element for buildings	136/246	126/633; 126/698; 126/703; 136/259; 359/19; 359/592; 359/597; 52/173.3; 52/780
3	US 20010050707 A1	<input checked="" type="checkbox"/> US - PGPUB	2001 1213	29	IMAGE RECORDING APPARATUS	347/255	
4	US 4566031 A	<input checked="" type="checkbox"/> US PAT	1986 0121	21	Spatial light modulation with application to electronically generated holography	348/40	348/302; 348/767; 359/296
5	US 3746785 A	<input checked="" type="checkbox"/> US PAT	1973 0717	8	DEFLECTABLE MEMBRANE OPTICAL MODULATOR	348/771	216/24; 216/65; 216/97; 359/291; 359/847; 65/31
6	US 5225920 A	<input checked="" type="checkbox"/> US PAT	1993 0706	13	Liquid crystal modulator including a diffuser with plural phase shifting regions	349/1	349/117; 349/137; 349/64

	Document ID	1	S o u r c e	Issu e Date	Pa ge s	Title	Current OR	Current XRef
7	US 5293272 A	<input checked="" type="checkbox"/>	U S P A T	1994 0308	18	High finesse holographic fabry-perot etalon and method of fabricating	359/1	356/457 ; 356/519 ; 359/3; 359/30; 359/900
8	US 20020001110 A1	<input checked="" type="checkbox"/>	U S - P G P U B	2002 0103	33	HOLOGRAPHIC LIGHT PANELS AND FLAT PANEL DISPLAY SYSTEMS AND METHOD AND APPARATUS FOR MAKING SAME	359/10	349/62; 359/15
9	US 4094575 A	<input checked="" type="checkbox"/>	U S P A T	1978 0613	11	Holographic article and process for making same	359/10	359/567 ; 359/569
10	US 6466354 B1	<input checked="" type="checkbox"/>	U S P A T	2002 1015	6	Method and apparatus for interferometric modulation of light	359/247	359/231 ; 359/290 ; 359/291 ; 359/295
11	US 5285308 A	<input checked="" type="checkbox"/>	U S P A T	1994 0208	47	Spatial light modulators for incoherent/coherent multiplexed holographic recording and readout	359/260	359/11; 359/216 ; 359/245 ; 359/261 ; 359/263 ; 359/276
12	US 20020054424 A1	<input checked="" type="checkbox"/>	U S - P G P U B	2002 0509	40	Photonic mems and structures	359/291	359/280 ; 359/292

	Document ID	1	S o u r c e	Issu e Date	Pa ge s	Title	Current OR	Current XRef
13	US 6055090 A	<input checked="" type="checkbox"/>	U S P A T	2000 0425	13	Interferometric modulation	359/291	345/84; 345/85; 359/579 ; 359/584 ; 359/589
14	US 6195196 B1	<input checked="" type="checkbox"/>	U S P A T	2001 0227	65	Array-type exposing device and flat type display incorporating light modulator and driving method thereof	359/295	349/64; 359/230 ; 359/245 ; 359/254 ; 359/291 ; 359/619 ; 362/31; 385/146
15	US 5943158 A	<input checked="" type="checkbox"/>	U S P A T	1999 0824	15	Micro-mechanical, anti-reflection, switched optical modulator array and fabrication method	359/295	359/290 ; 359/291 ; 359/318
16	US 4854674 A	<input checked="" type="checkbox"/>	U S P A T	1989 0808	7	Process for improving holographic efficiency	359/3	359/15; 359/900
17	US 3677617 A	<input checked="" type="checkbox"/>	U S P A T	1972 0718	5	TECHNIQUES OF HOLOGRAPHIC DATA REDUCTION UTILIZING AN ADDITIONAL DIFFUSING STRUCTURE DURING RECONSTRUCTION	359/30	359/33
18	US 20010055208 A1	<input checked="" type="checkbox"/>	U S - P G P U B	2001 1227	21	Optical element, optical light source unit and optical display device equipped with the optical light source unit	362/260	349/115 ; 362/26; 362/293 ; 362/31; 362/318

	Document ID	1	S o u r c e	Issu e Date	Pa ge s	Title	Current OR	Current XRef
19	US 6255038 B1	<input checked="" type="checkbox"/>	U S P A T	2001 0703	10	Process for modulating interferometric lithography patterns to record selected discrete patterns in photoresist	430/316	430/311 ; 430/312 ; 430/313 ; 430/314 ; 430/323 ; 430/394 ; 430/396